

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Branco et al.

Serial No.: 09/617,454

Filed: July 17, 2000

Title: Method for Cleaning Plasma Etch
Chamber Structures

Attorney Docket No.: CY-0015

Group Art Unit: 1746

Examiner: Markoff, A.

RECEIVED
CENTRAL FAX CENTER

MAR 16 2004

OFFICIAL

RESPONSE TO OFFICE ACTION

- 5 Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

10

A. Introductory Comments

The following is submitted in response to the Office Action dated December 17, 2003,
and is currently due March 17, 2004.

15

20

25

37 C.F.R. §1.8

I hereby certify that this correspondence is being

30

☒ transmitted via facsimile to the United States Patent and Trademark Office to fax number: 1-703-872-9306Date of Transmittal: MARCH 16, 2004☐ deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450.

35

Date of Deposit: _____

Typed/Printed Name: Bradley T. Sako

40

Signature: Bradley T. Sako